

INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Not for submission under 37 CFR 1.99)</i>	Application Number		10519337	
	Filing Date		2004-12-22	
	First Named Inventor		Nancy Dean	
	Art Unit		1794	
	Examiner Name		Kevin R. Kruer	
	Attorney Docket Number		H0004275.68586 US - 4018	

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